

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. MASUDA, et al  
Serial No.: 09/421,043  
Filed: October 20, 1999  
For: PLASMA ETCHING APPARATUS AND PLASMA ETCHING  
METHOD  
Group: 1763  
Examiner: A. Mulero

# 25  
6/24/03  
mw

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR 1.97 & 1.98**

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 6, 2003

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith a copy of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration, noting that such documents were cited in copending application Serial No. 09/421,044.


This information disclosure statement is being submitted with the RCE accompanying this paper.

To the extent that, the documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language translation of the foreign documents.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (520.34403CV4) and please credit any excess fees to such deposit account.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Melvin Kraus", is written over a horizontal line.

Melvin Kraus  
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ANTONELLI, TERRY, STOUT & KRAUS, LLP

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